

MICRO-428 **Metrology**

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Cursus	Sem.	Type
Microtechnics	MA2, MA4	Opt.

Language of **English** teaching Credits Session Summer Semester Spring Exam Oral Workload 90h Weeks 14 3 weekly Hours 3 weekly Courses Number of positions

Summary

The course deals with the concept of measuring in different domains, particularly in the electrical, optical, and microscale domains. The course will end with a perspective on quantum measurements, which could trigger the ultimate revolution in metrology.

Content

The course deals with the concept of measuring in different domains, particularly in the electrical, optical, and microscale domains. The concept of precision, accuracy, and resolution will be introduced early in the course with an embedded course on statistics, which provide the basics required to understand how proper measurements ought to be performed. Subsequently, the course will introduce electrical, optical, and mechanical metrology techniques dealing with intrinsic and extrinsic limitations of the measurement. The course will end with a perspective on quantum measurements, which could trigger the ultimate revolution in metrology. Homework will be used as a means to practice the concepts learnt in class. **Syllabus**

- Classical metrology
- Basic statistics
- Electrical metrology
- Optical microscopy
- Optical imaging
- Time
- AFM
- SEM
- Quantum metrology

Keywords

Accuracy, precision, resolution, reproducibility, reliability, fidelity of the measurement

Learning Prerequisites

Required courses

Basic mathematics/physics

Recommended courses

Design of experiments

Learning Outcomes

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By the end of the course, the student must be able to:

- Develop measurement setups that yield reproducible results
- Analyze the accuracy and precision of a measurement for a certain resolution
- Interpret the quality of data from measurements

Assessment methods

Self-assessment (ungraded homework, exercise session presence verified); final exam during exam sessions.

Resources

Notes/Handbook

Specialized labs, references TBD.

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